PTO/SB/08a (05-07)
Approved for use through 09/30/2007. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE Under the Paperwork Reduction Act of 1995, no person are required to respond to a collection of information unless it contains a valid OMB control number.

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Not for submission under 37 CFR 1.99)

<i>l</i>						
Application Number		10645773				
Filing Date		2003-08-21				
First Named Inventor	Hideh	hiko Kawaguchi				
Art Unit		1746				
Examiner Name	B. S.	Carrillo				
Attorney Docket Number		KAMMON 3.0-069 CONT				

					0.3.1	AIENIS				
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date		Name of Pate of cited Docu	entee or Applicant Iment	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear		
	1									ï
If you wish	n to ac	ldd additional U.S. Pate	nt citatio	n inform	ation pl	ease click the	Add button.			
			U.S.P	ATENT	APPLIC	CATION PUB	LICATIONS			
Examiner Initial*	Cite No	Publication Number 1		ition	Name of Patentee or Applicant of cited Document			Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear		
	1									
If you wisl	n to a	dd additional U.S. Publi	shed Ap	plication	citation	n information _l	please click the Ado	d butto	n.	
				FOREIG	SN PAT	ENT DOCUM	IENTS			
Examiner Initial*	Cite No	Foreign Document Number ³	Country Code ² i		Kind Code ⁴	Publication Date	Name of Patentee or Applicant of cited Document		Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear	Т5
1	1	11082504	JP			1999-03-26	Nippon Seiko Kk		F -	×
2	2	60034612	JP			1985-02-22	Toray Industries			×
3	3	62280700	JP			1987-12-05	Hitachi Ltd			

U.S.PATENTS

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)			Application Number				10645773				
			Filing Date				2003-08-21				
			First Named Inventor Hideh				niko Kawaguchi				
			Art Unit				1746				
			Examiner Name B. S.			B. S.	Carrillo				
			Attorney Docket Number			er	KAMMON 3.0-069 CONT				
4	4	19738147	DE			1999-03-04		Steag Micro Tech Gmbh		X	
If you wisl	h to ac	ld additional Foreign P	atent Doc	ument	citation	informatio	n plea	ase click the Add buttor	ו		
			NON-	PATE	NT LITE	RATURE	DOC	UMENTS			
Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.								T 5	
	1										
If you wish to add additional non-patent literature document citation information please click the Add button											
EXAMINER SIGNATURE											
Examiner Signature Date Considered											
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.											

¹ See Kind Codes of USPTO Patent Documents at <u>www.USPTO.GOV</u> or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁴ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language translation is attached.